



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Ellison et al. : Attorney Docket: 31257-252090

Application No.: 10/526,059 : Art Unit: 4174

Filed: October 13, 2005 : Examiner: N. Gugliotta

Title: LIGHTLY DOPED SILICON CARBIDE WAFER AND USE THEREOF IN HIGH POWER DEVICES

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the office action issued November 15, 2007, please amend the above-identified application as follows: